

Docket number (Optional)

15689.73

Application Number

09/889,000

## INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Applicant(s)

Shinji Uebayashi et al.

Filing Date

June 22, 2001

Group Art Unit

2616

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
	1	JP 07-212817	08/11/1995	Japan	H04Q7	22	X	

EXAMINER

DATE CONSIDERED

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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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**Official Notice of Rejection; Case No.: DCMH120076; Patent Application No.: 2000-190173**

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